

ABSTRACT OF THE DISCLOSURE

A cleaning device for cleaning a nozzle surface of an ink-jet head has a first wiping member for wiping a nozzle surface of an ink-jet head and a second wiping member for wiping the first wiping member, and a lever driving mechanism for moving the first wiping member between a retracted position located away from the nozzle surface and a wiping position for wiping the nozzle surface. The second wiping member is formed of an elastic body and is arranged within a moving path of the first wiping member, so that it contacts with the first wiping member for only a limited period, whereby reducing in wear of these wiping members.